

**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE - EXAMINING GROUP 2820**

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Gabriele Barlocchi et al.
Application No. : 10/667,113
Filed : September 18, 2003
For : METHOD FOR FORMING HORIZONTAL BURIED CHANNELS
OR CAVITIES IN WAFERS OF MONOCRYSTALLINE
SEMICONDUCTOR MATERIAL

Examiner : Fazli Erdem
Art Unit : 2826
Docket No. : 854063.552D1
Date : March 11, 2008

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Commissioner for Patents:

In response to the Office Action dated January 11, 2008, please amend the application as follows:

Remarks begin on page 2 of this paper.